

100

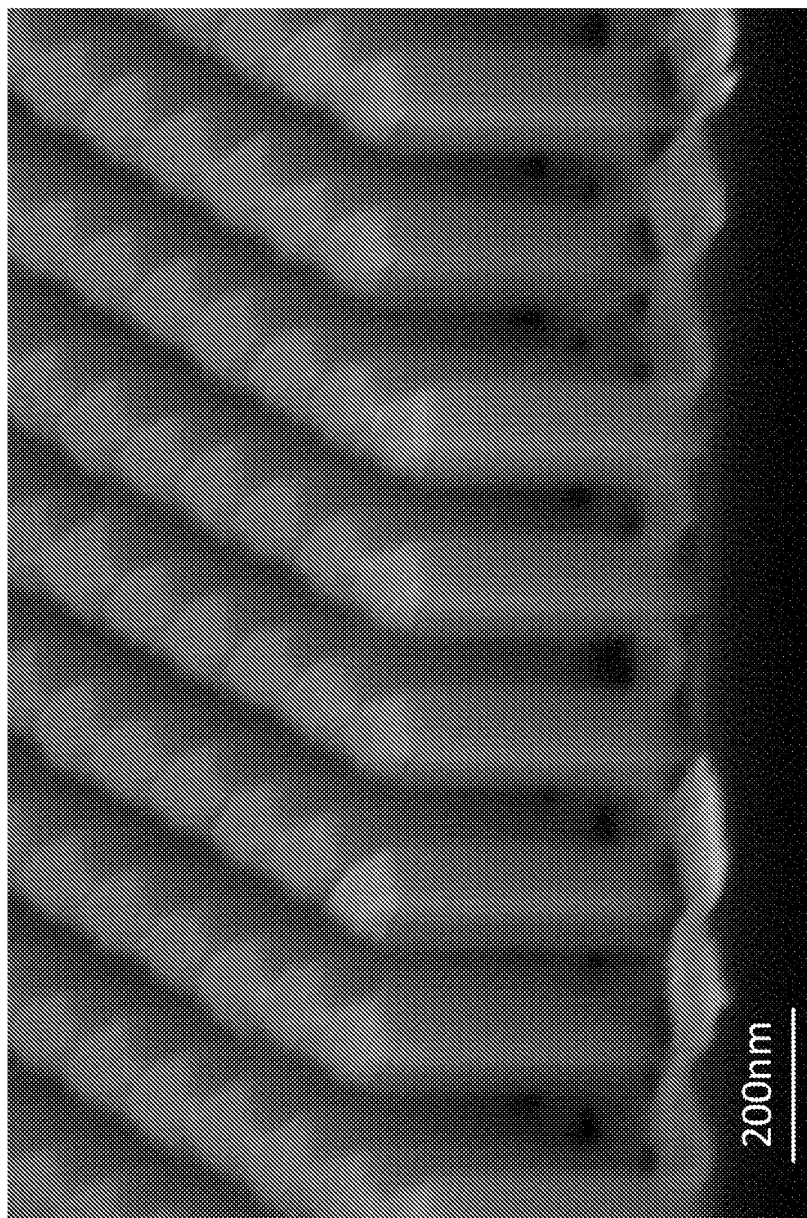


FIG. 1

200

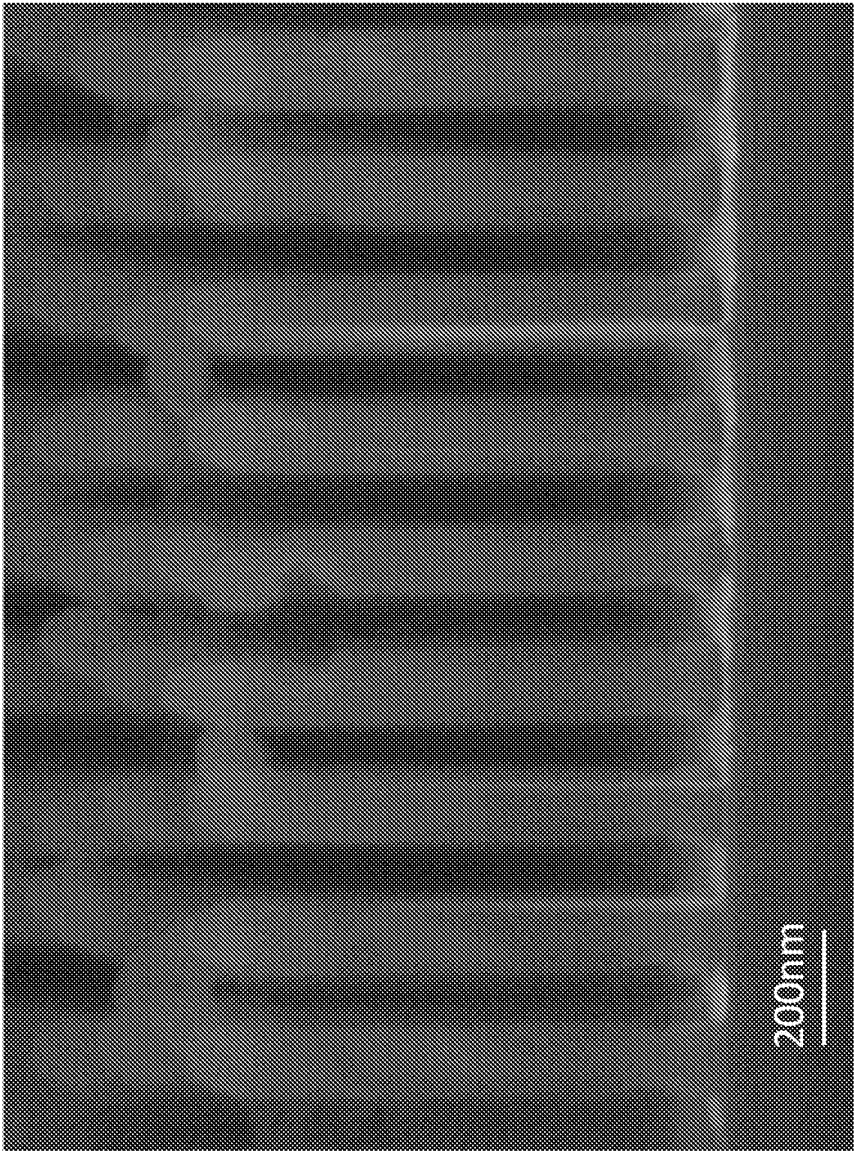


FIG. 2

300

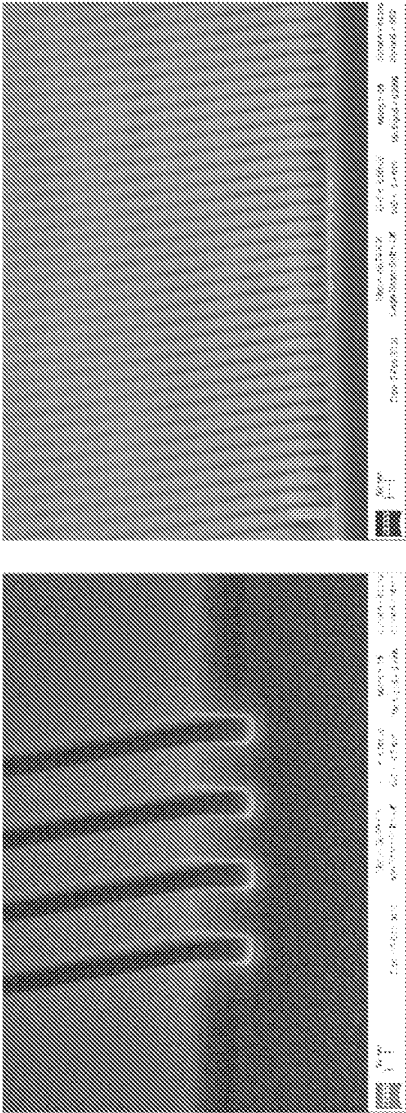


FIG. 3

400

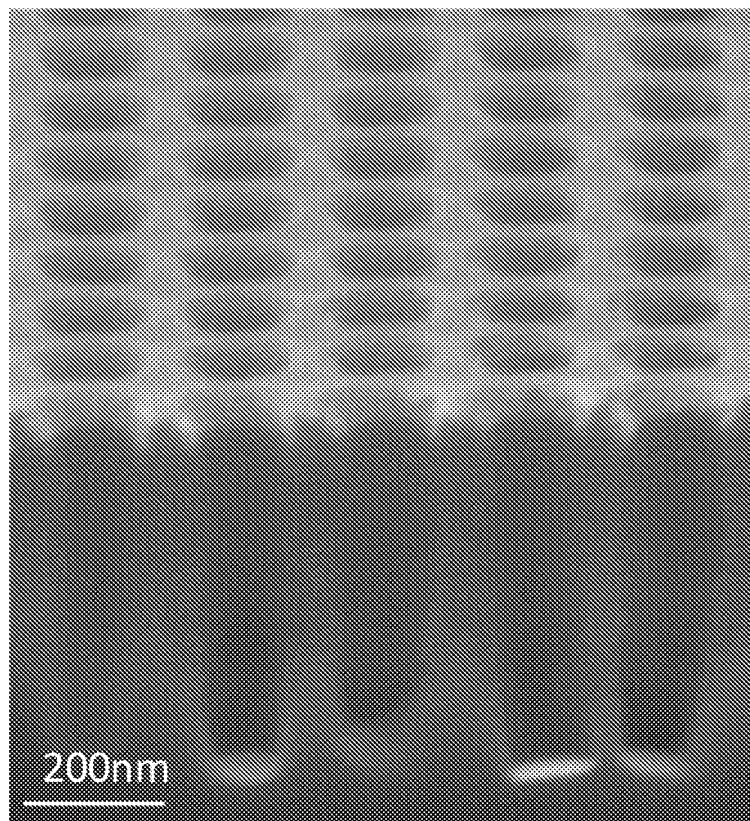


FIG. 4

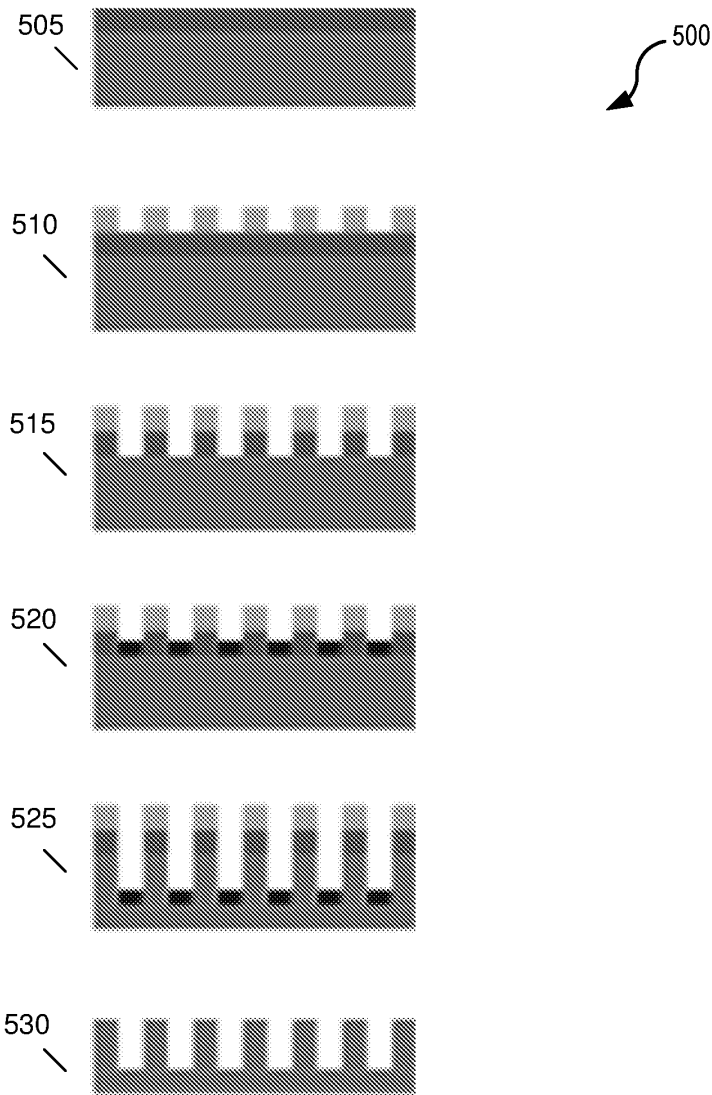


FIG. 5

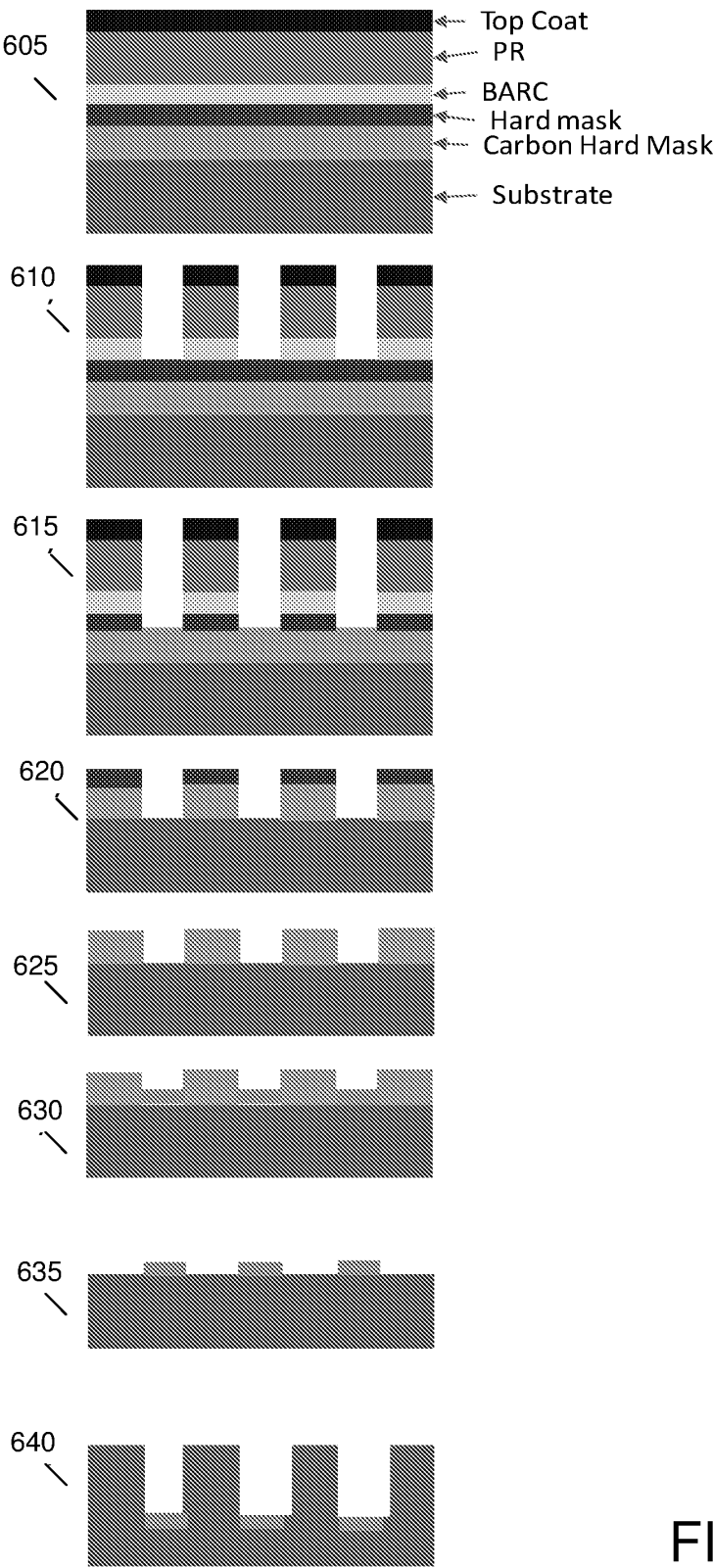


FIG. 6

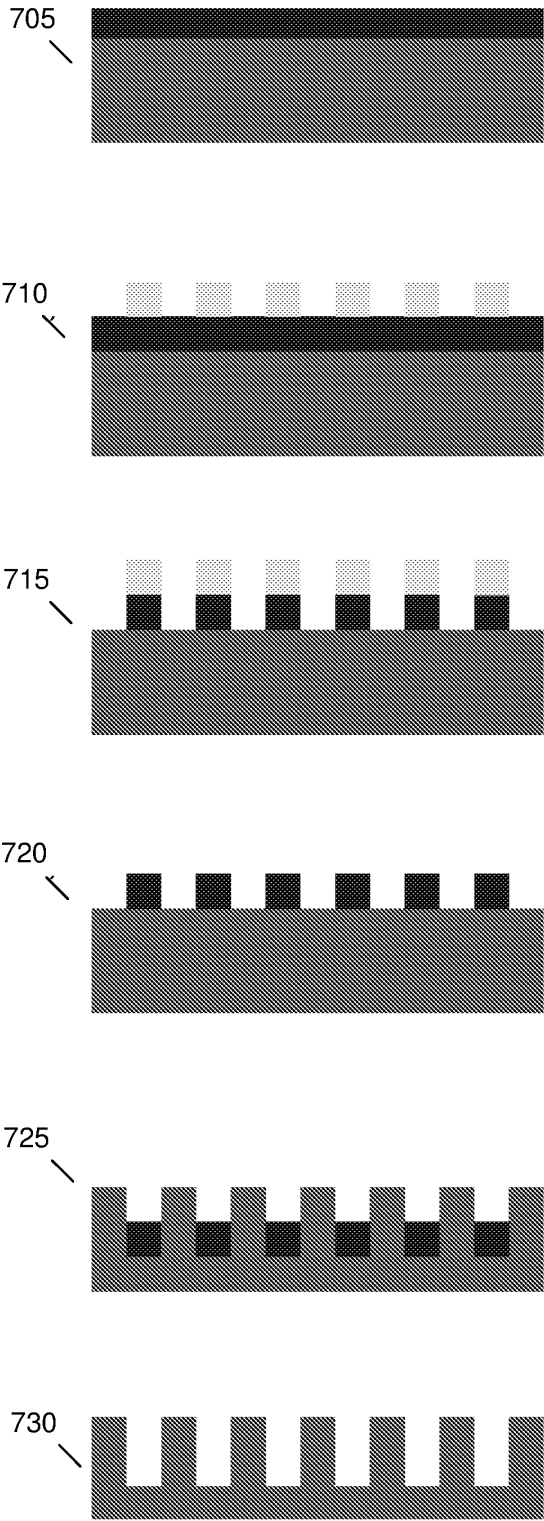


FIG. 7

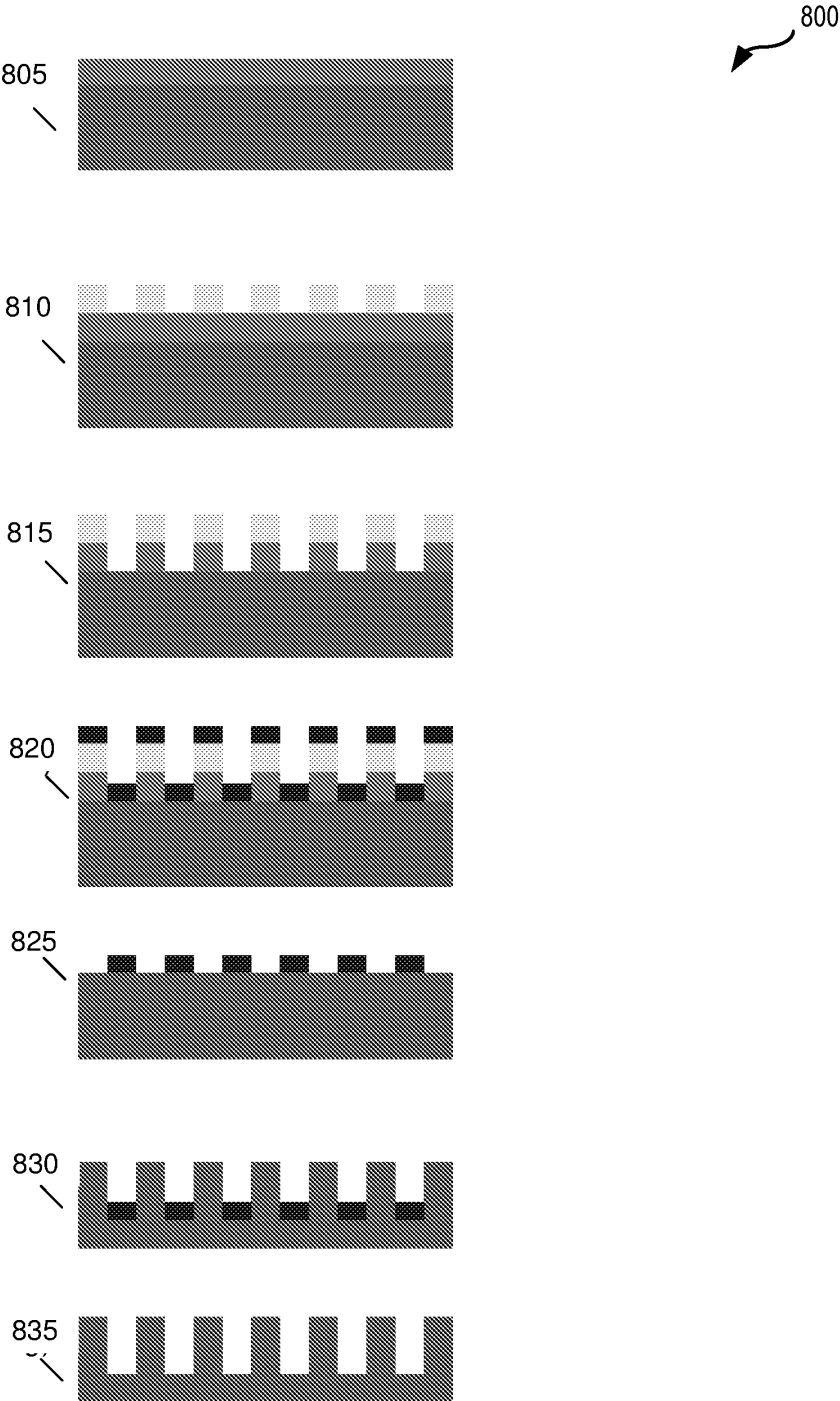


FIG. 8

900

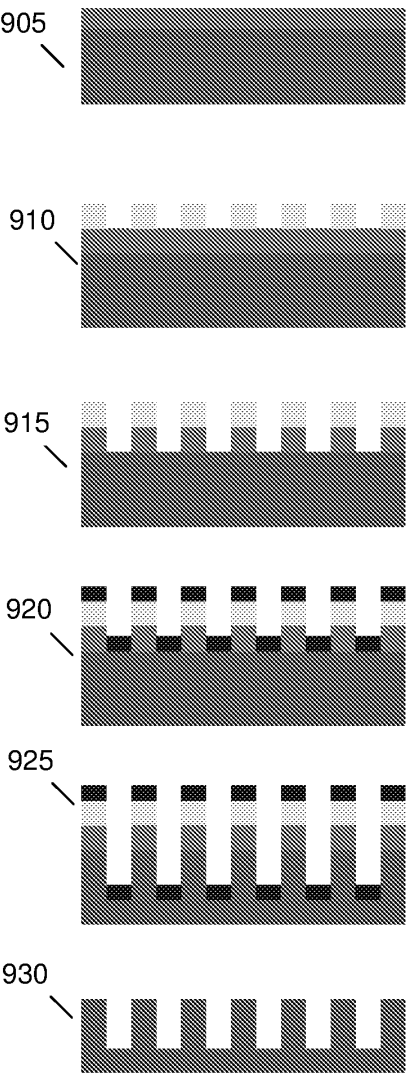


FIG. 9

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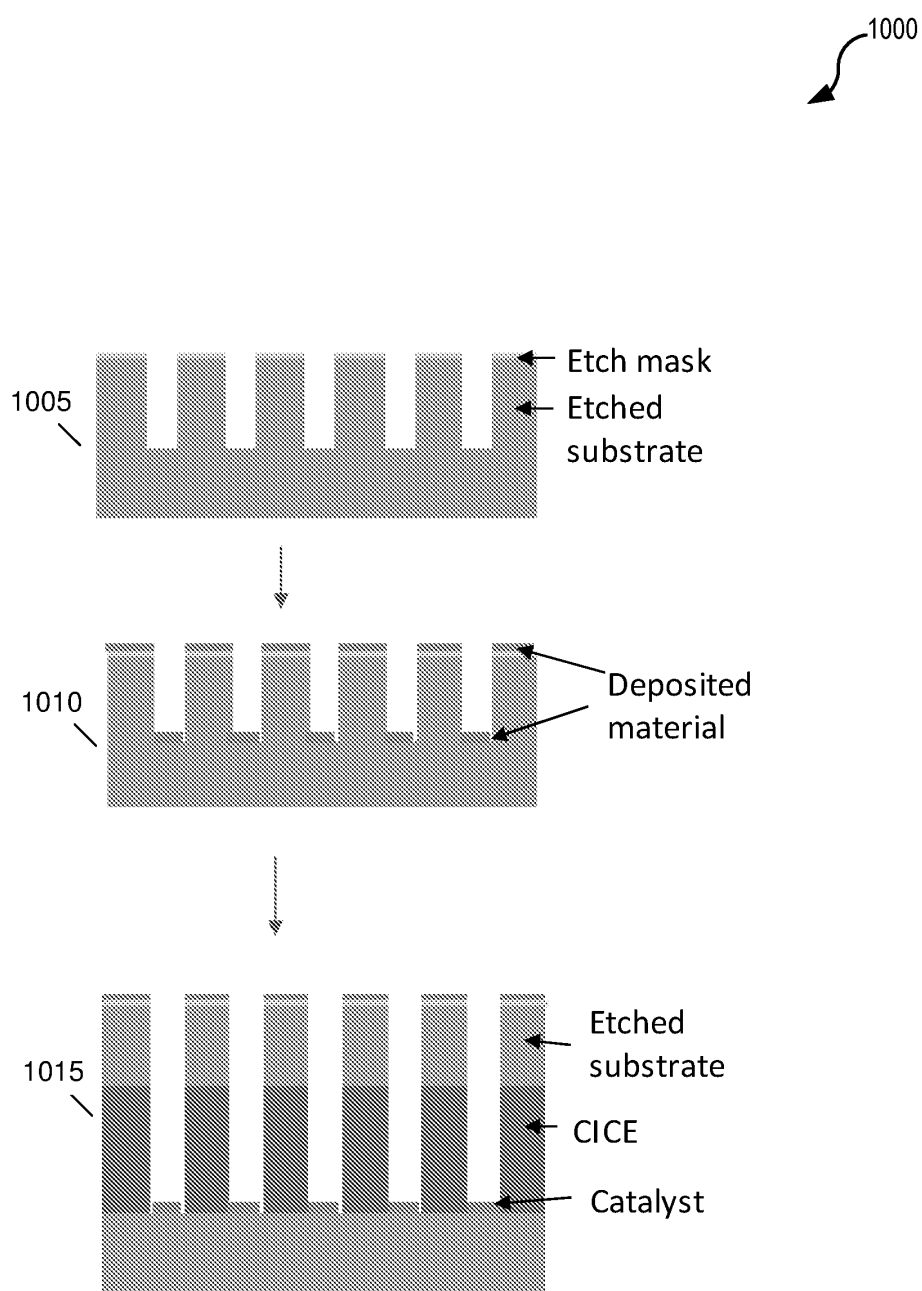


FIG. 10

11/24

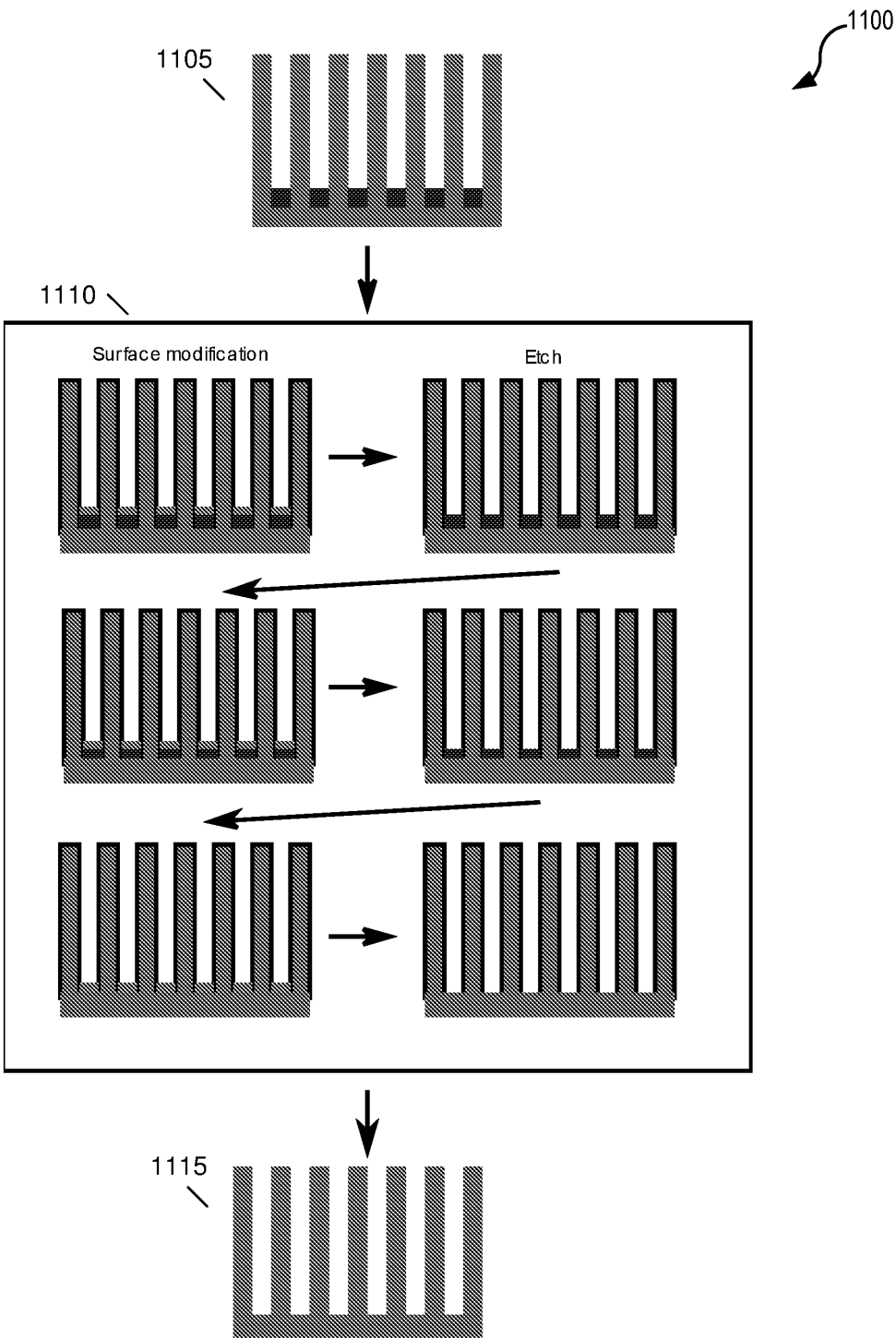


FIG. 11

12/24

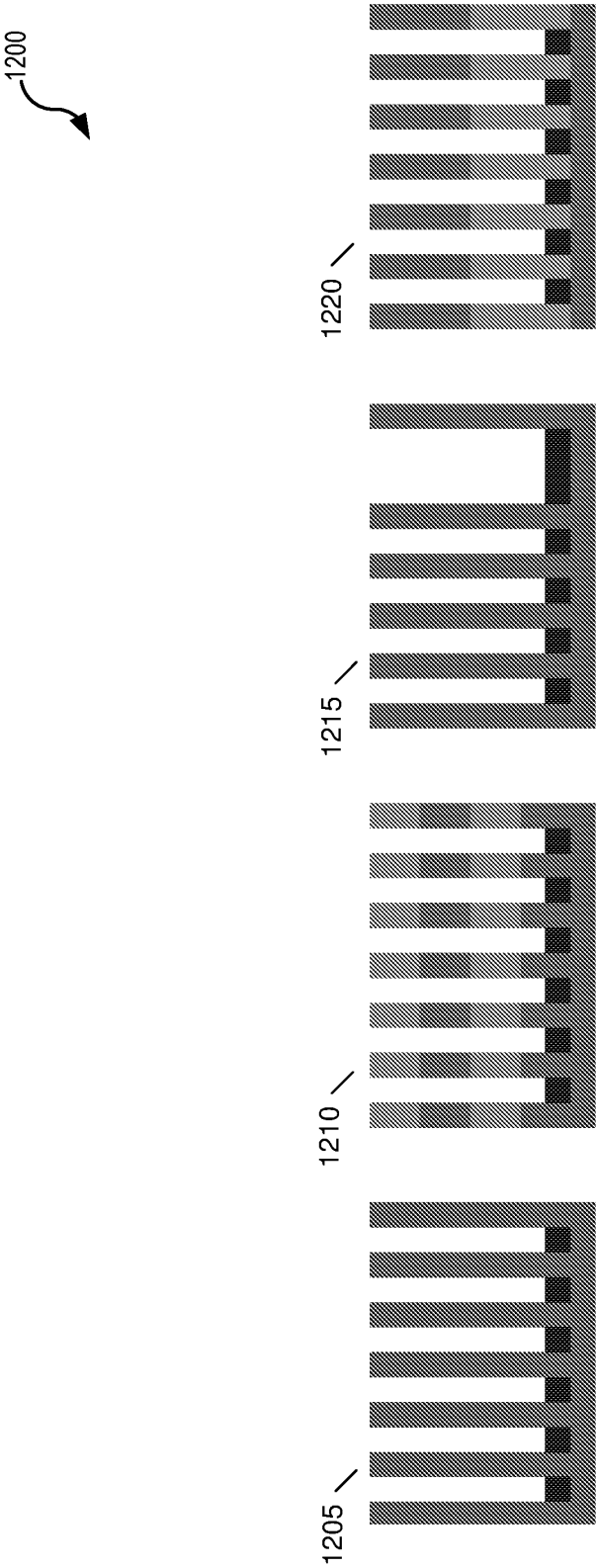


FIG. 12

1300

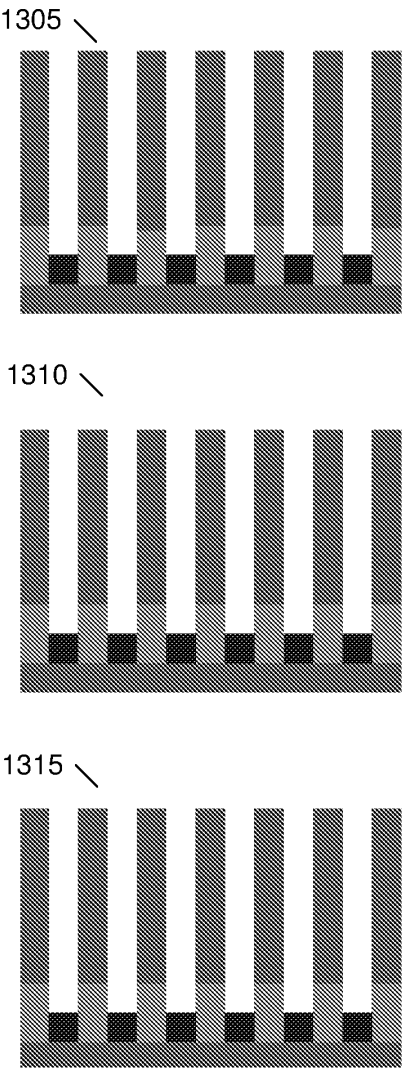


FIG. 13

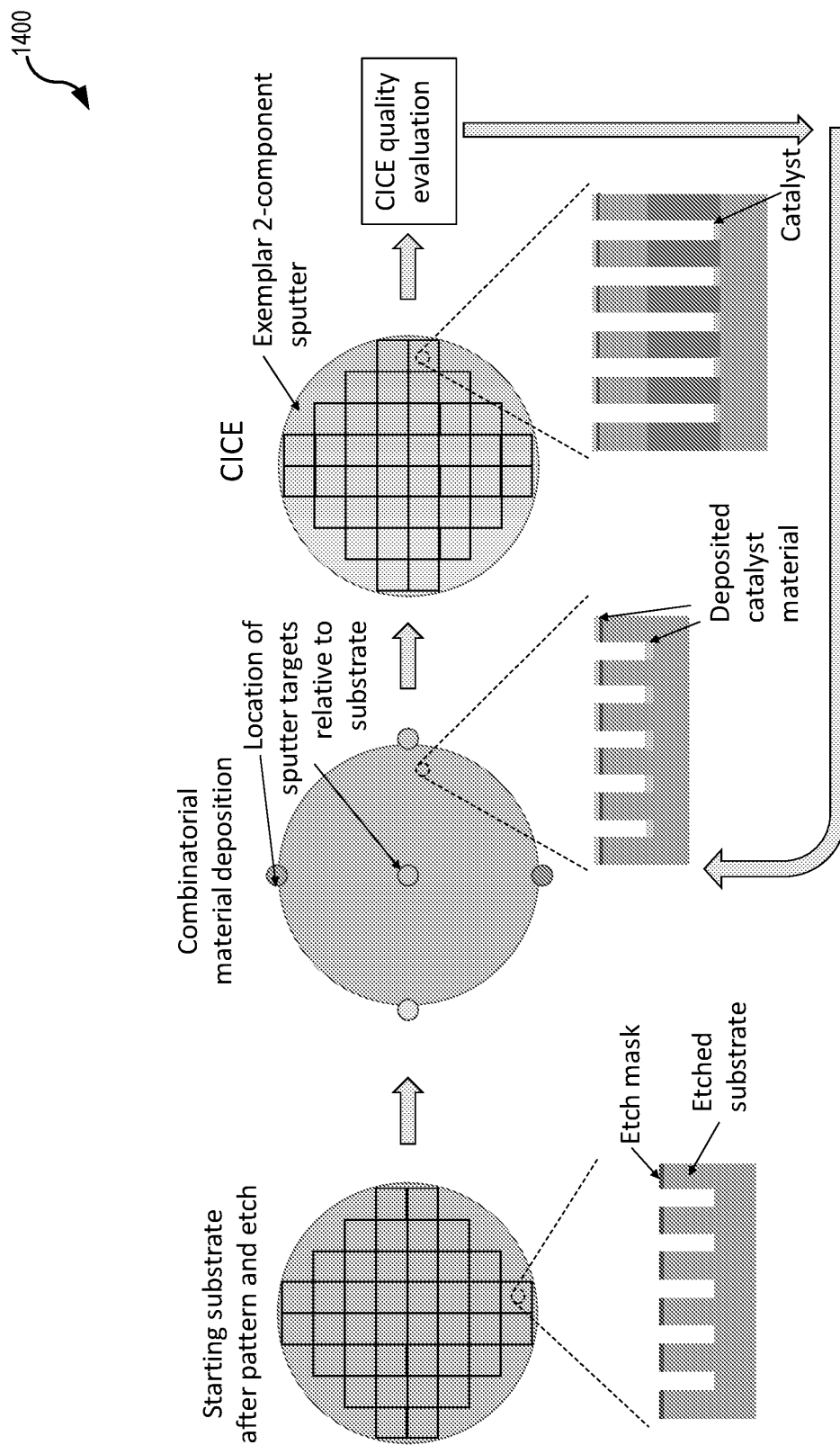
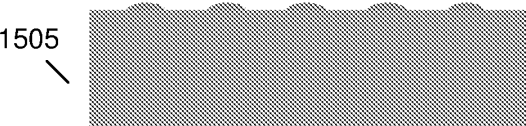


FIG. 14

1500



Pattern catalyst



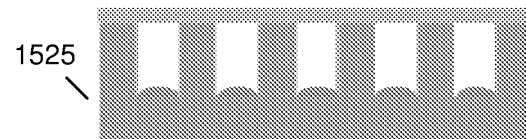
Short CICE



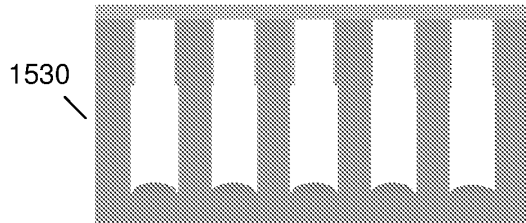
Deposit low surface energy layer



Anisotropic removal of layer to re-expose the catalyst



Optional Deposition of ceiling



Long CICE

FIG. 15

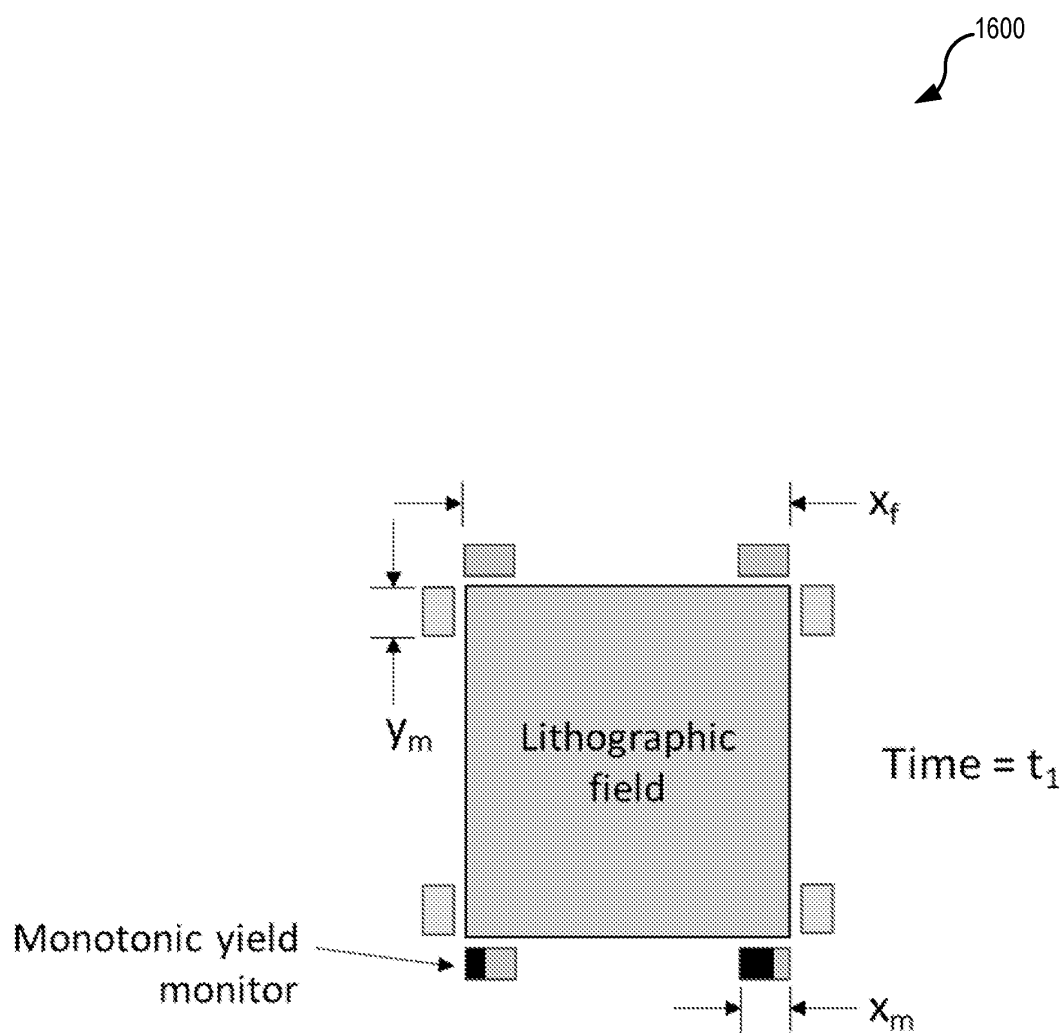


FIG. 16

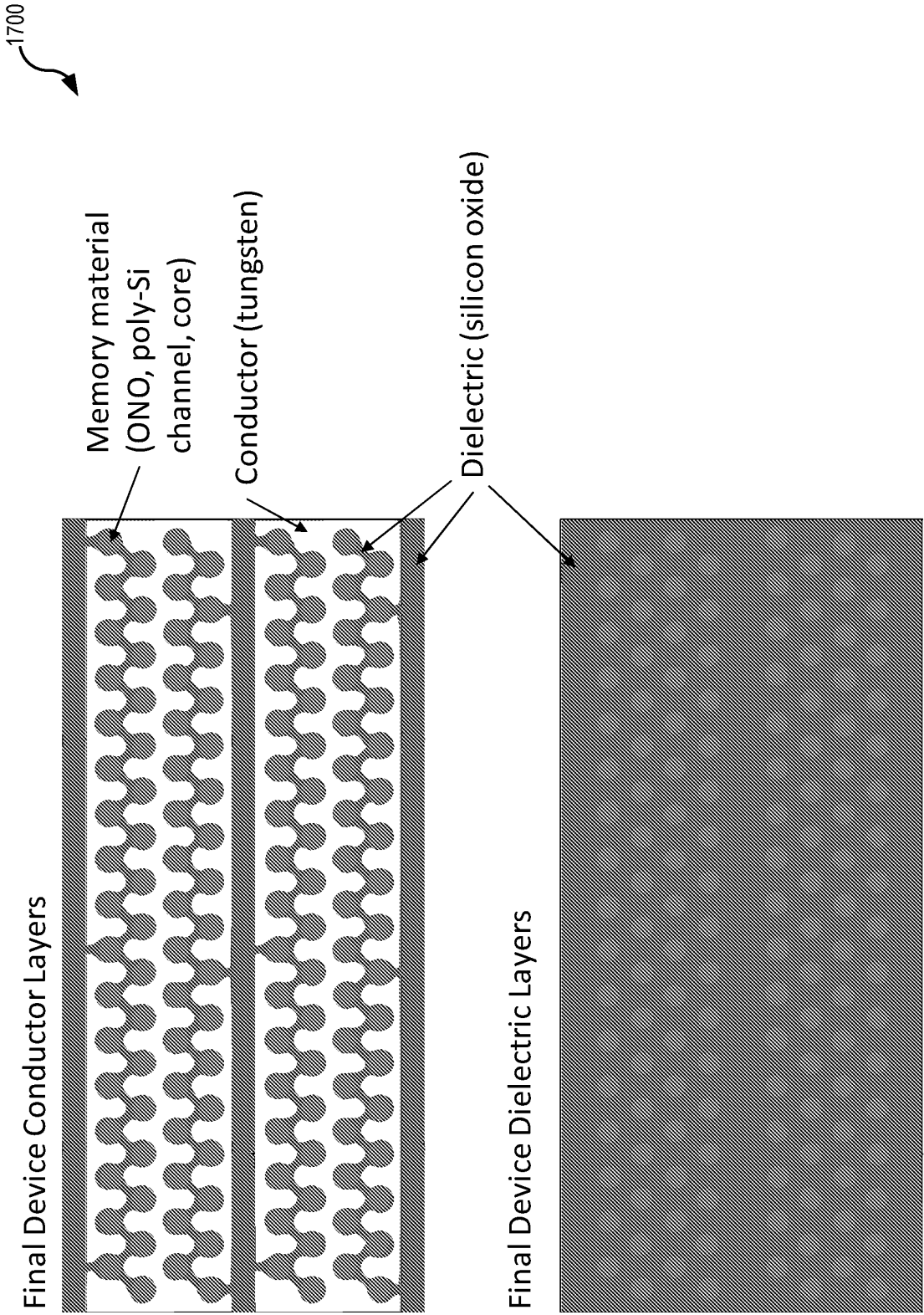


FIG. 17

1800

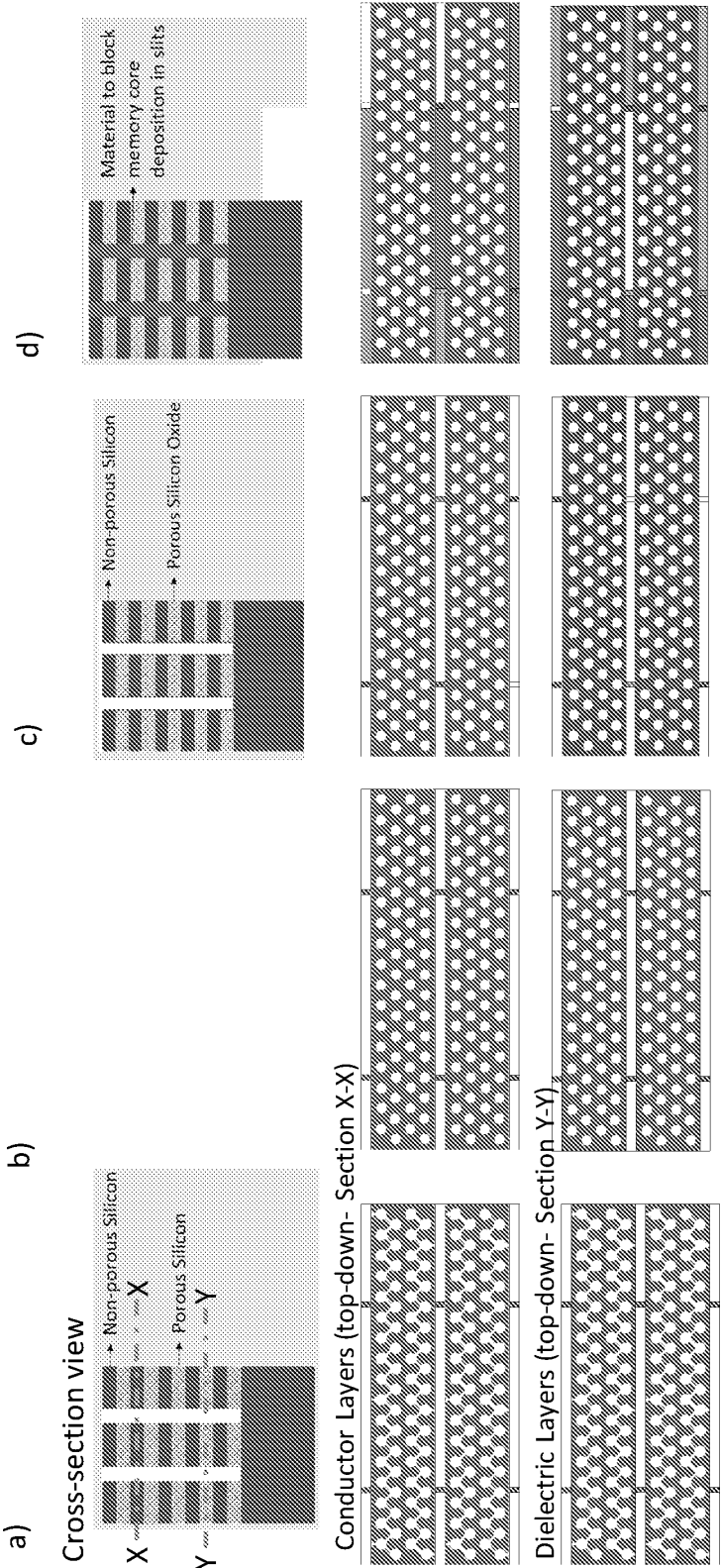


FIG. 18

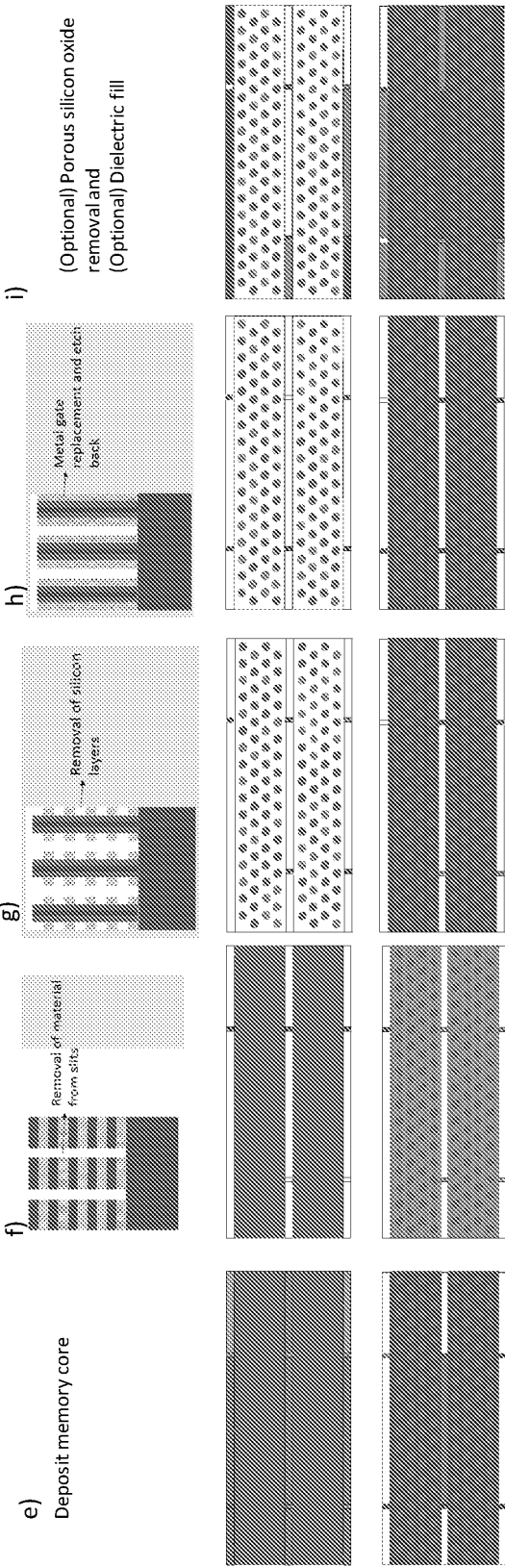


FIG. 18 (CONTINUED)

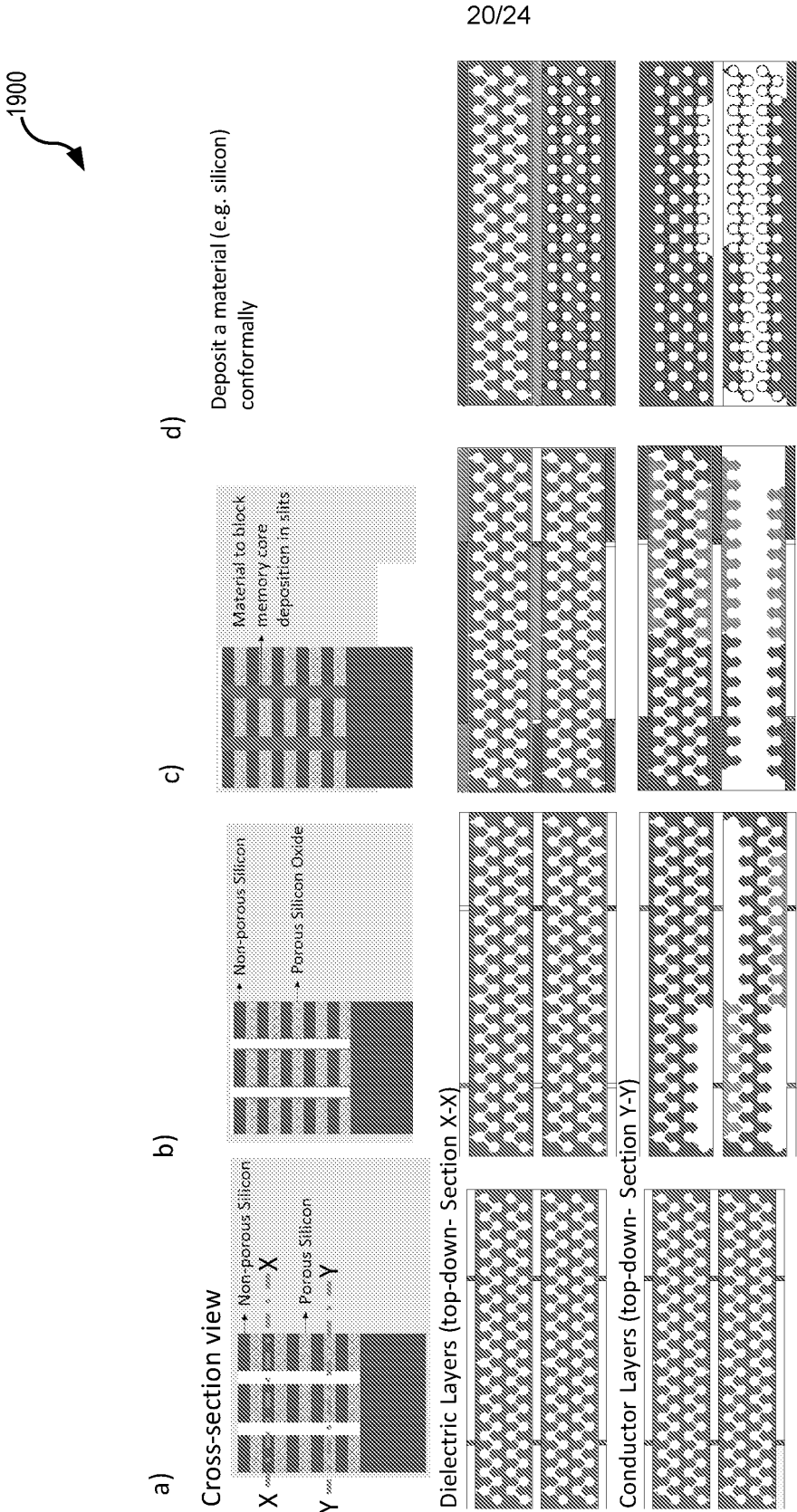


FIG.19

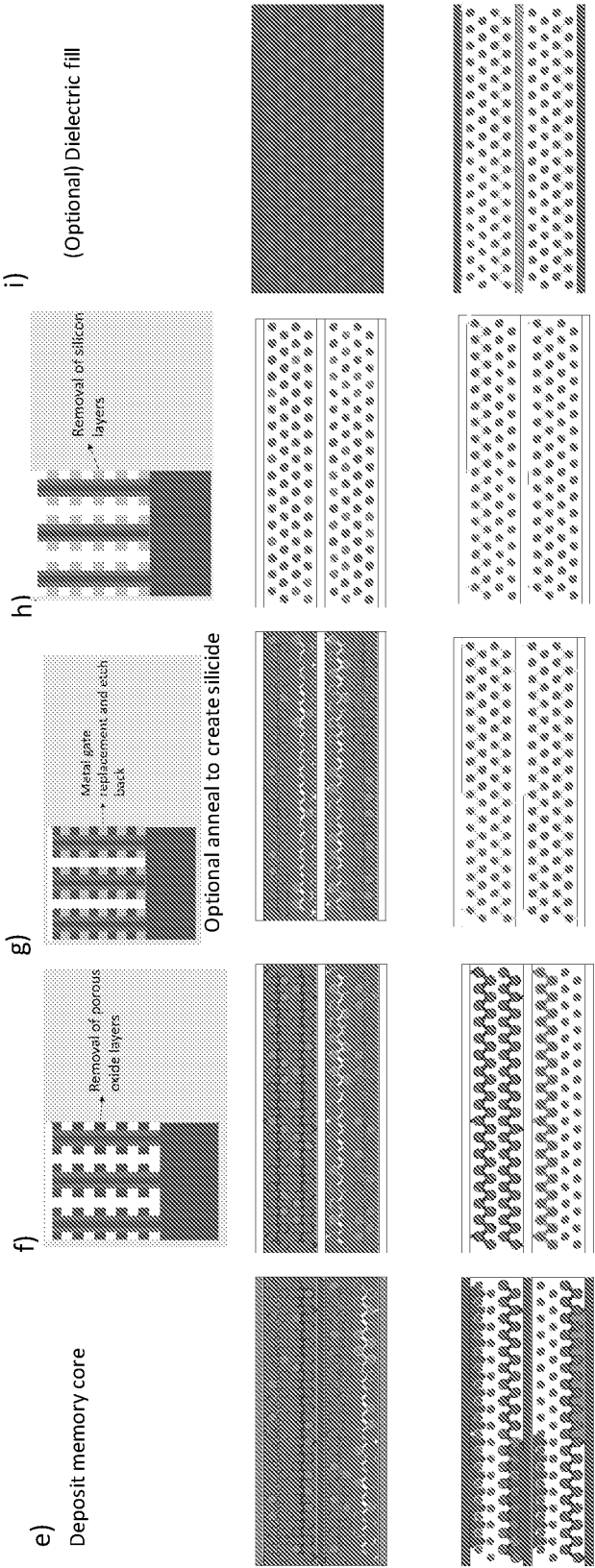


FIG. 19 (CONTINUED)

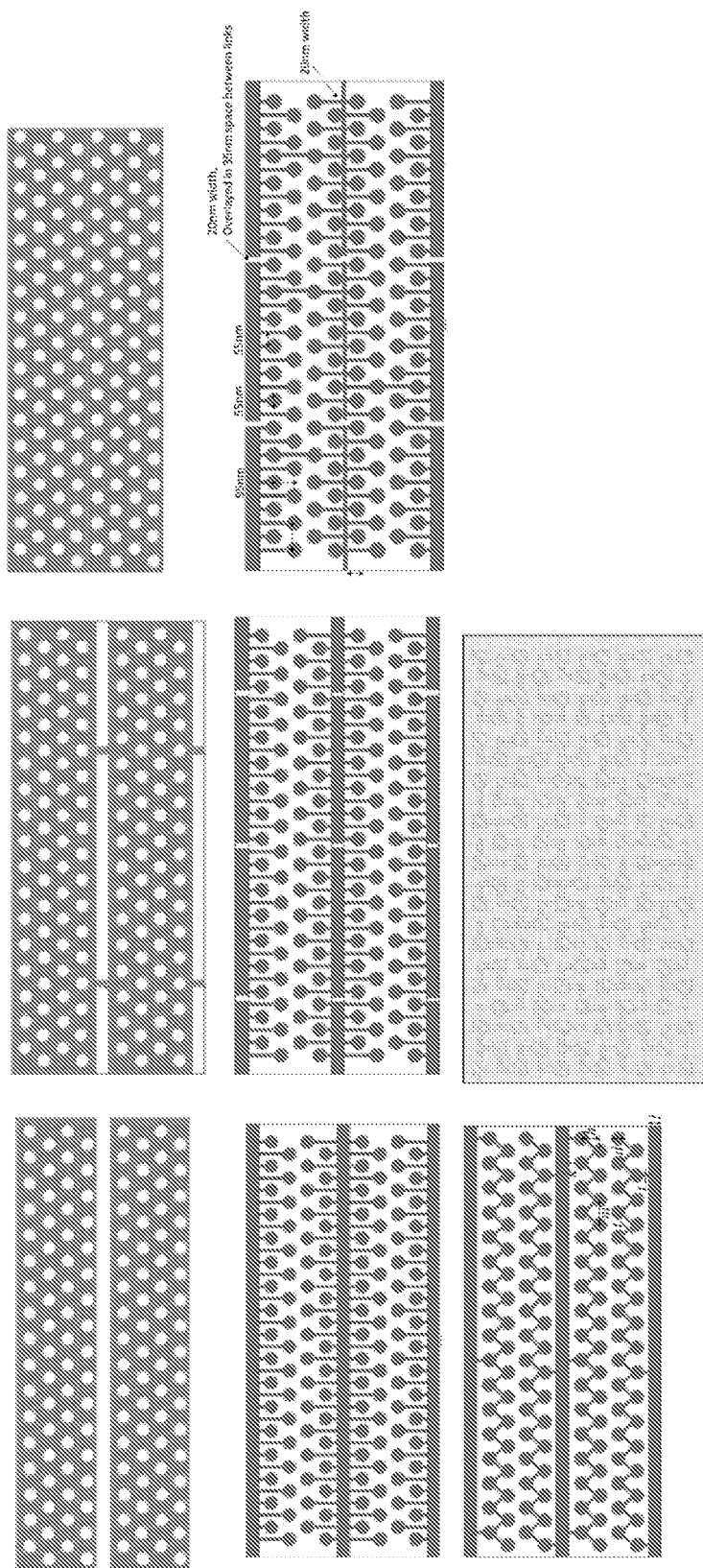
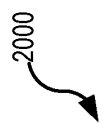


FIG. 20

2100

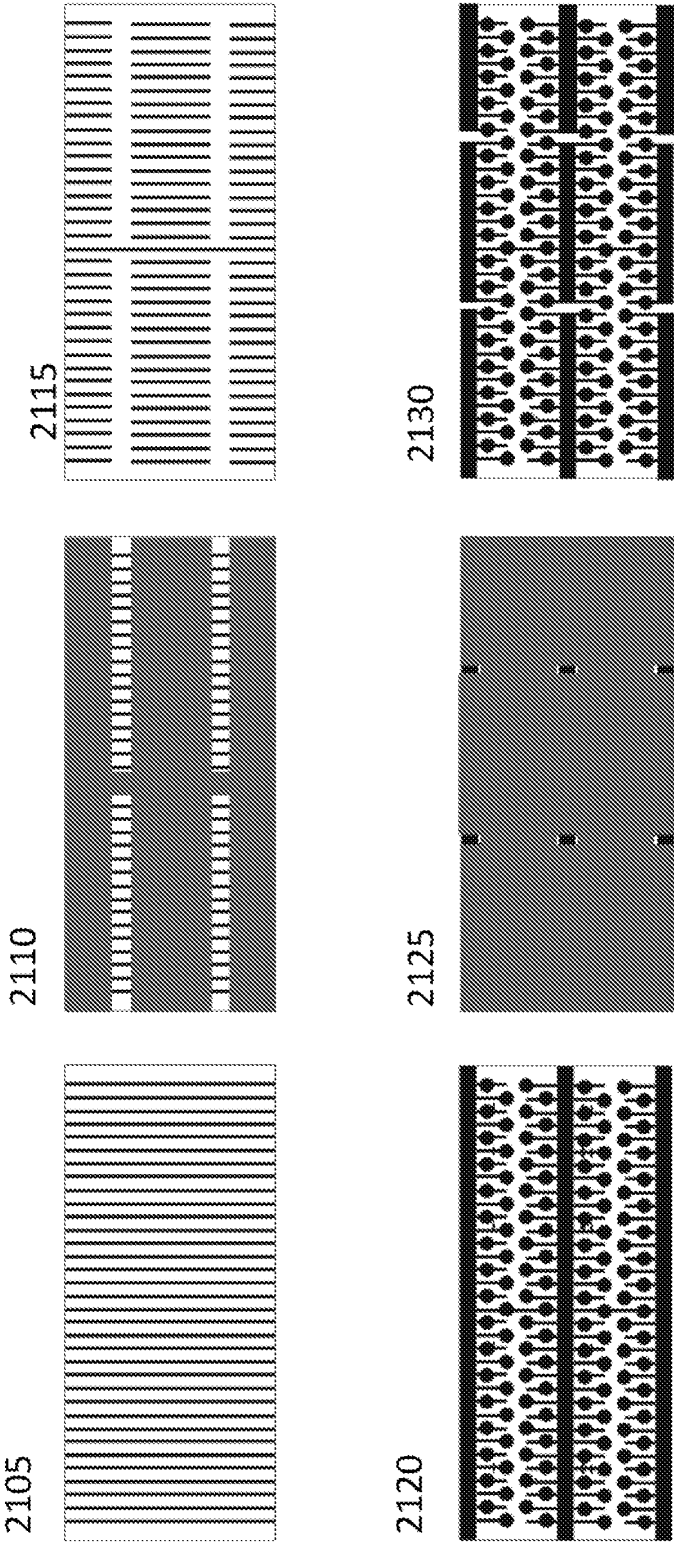


FIG. 21

2200

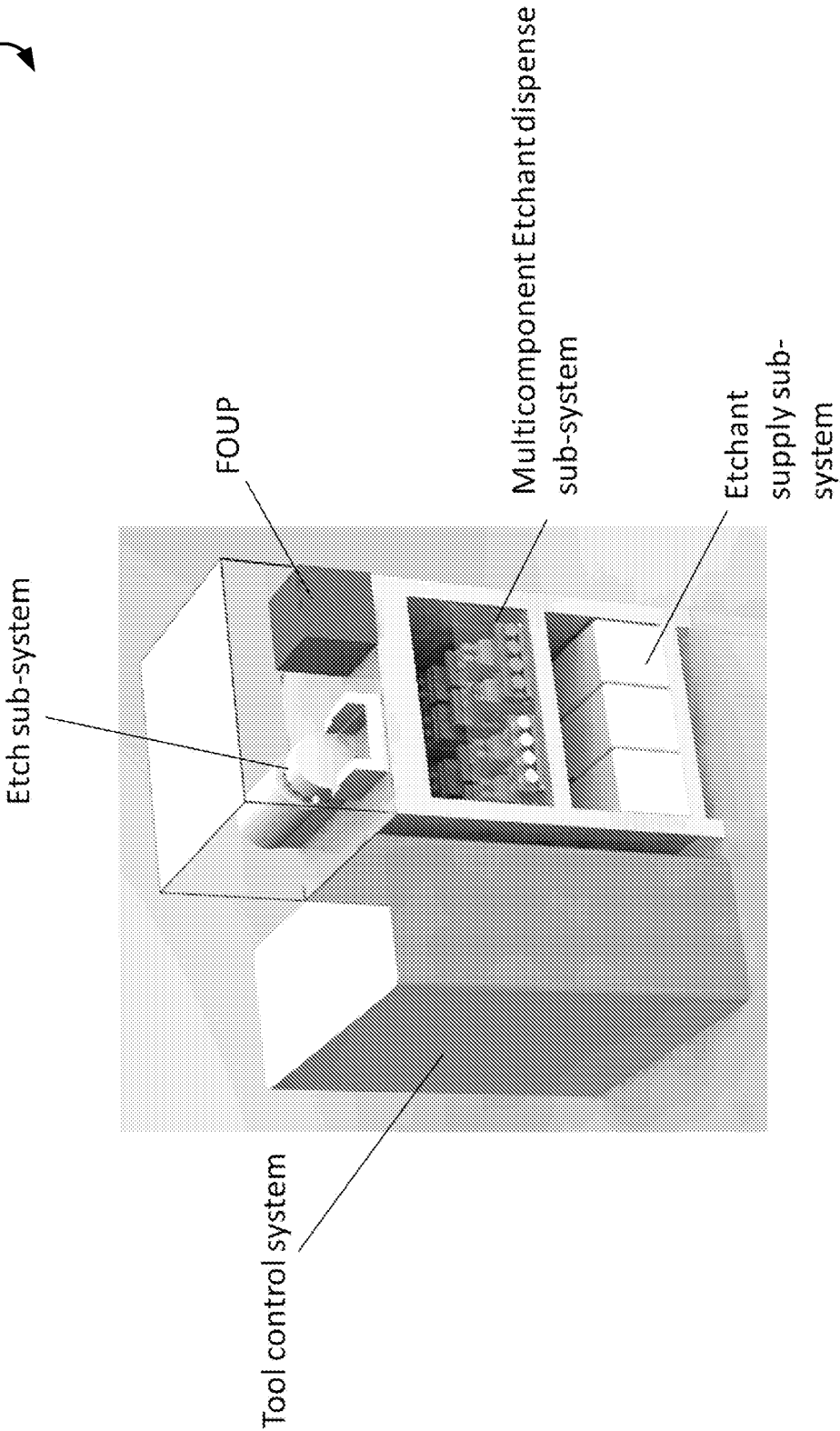


FIG. 22